Docket No.: S8810.0003/P003

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Masashi Kawasaki et al.

Application No.: 10/588,283 Confirmation No.: 5019

Filed: July 23, 2007

Art Unit: 1794

For: METHOD OF MANUFACTURING THIN

FILM, METHOD OF MANUFACTURING p-

TYPE ZINC OXIDE THIN FILM AND

SEMICONDUCTOR DEVICE

Examiner: J. C. Langman

RESPONSE TO RESTRICTION REQUIREMENT

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Madam:

In response to the restriction requirement set forth in the Office Action mailed March 30, 2009, Applicant hereby elects Group 1, claims 1-9, and 21, drawn to a method, for continued examination with traverse.

If the search and examination of all the claims in an application can be made without serious burden, the examiner must examine them on the merits, even though they include claims to independent or distinct inventions. *MPEP* 803. The Office Action has failed to show that it would be a serious burden on the Examiner to examine all claims. Therefore, the election requirement is improper and should be withdrawn.

Application No.: 10/588,283 Docket No.: S8810.0003/P003

Applicants respectfully request that the restriction be withdrawn and all claims examined.

Dated: April 30, 2009

Respectfully submitted,

ву / СМУ #41.1

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